For: METHOD AND APPARATUS FOR WAFER MECHANICAL STRESS MONITORING AND WAFER

THERMAL STRESS MONITORING

CERTIFICATE OF MAILING

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22313-1450 on February 13, 2006.

Signed: Generalla

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Mail Stop: RCE Commissioner for Patents Alexandria, VA 22313-1450 Sir: 1. Submission required under 37 C.F.R. § 1.114 a. Previously submitted Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on January 13, 2006. Consider the arguments in the Appeal Brief or Reply Brief previously filed on _ b. Enclosed Amendment/Reply Affidavit(s)/Declaration(s) ii. ☐ Information Disclosure Statement (IDS) iii. Miscellaneous a. Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of _____ months. b. Other 2. Fees Check in the amount of \$790.00 is enclosed for: RCE fee required under 37 C.F.R. § 1.17(e); i. 2 Month Extension of time fee, of which \$120.00 has been previously ii. paid on January 13, 2006 (37 C.F.R. §§ 1.136 and 1.17); and Other b. Market The Director (or the Commissioner) is hereby authorized to charge the RCE fee of \$790 and the extension fee of \$330 (\$1120.00) to Deposit Account No. 50-0805 (Order No. LAM2P438). Date:

02/17/2006 MAHMED1 00000063 500805 10671978

Michael L. Gencarella, Esq. Registration No.: 44,703

01 FC:1801 02 FC:1252 790.00 DA 330.00 DA